



ELECTRONIC COPY

LG776673864
Report verification at igi.org



February 21, 2026

IGI Report Number **LG776673864**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **7.43 - 7.49 X 4.57 MM**

GRADING RESULTS

Carat Weight **1.58 CARAT**

Color Grade **E**

Clarity Grade **VVS 2**

Cut Grade **EXCELLENT**

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ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

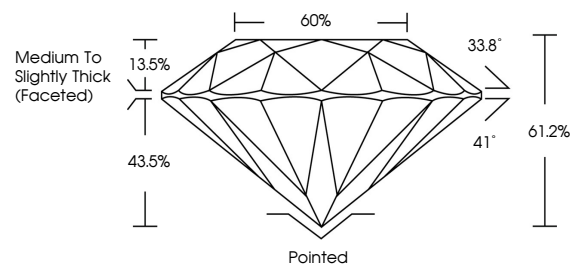
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **LG776673864**

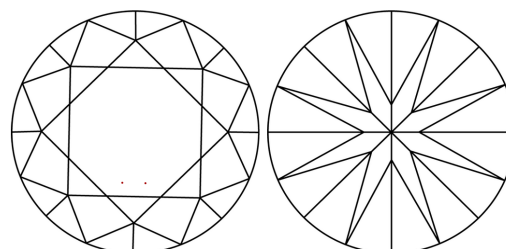
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

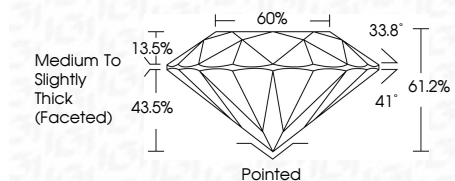
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VVS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

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IGI



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IGI Report No LG776673864
ROUND BRILLIANT

1.58 CARAT
E
Color Grade
VVS 2
Clarity Grade
EXCELLENT
Depth
61.2%
Table
60%
Girdle
Medium To Slightly Thick (Faceted)

Pointed
Polish
EXCELLENT
Symmetry
EXCELLENT
Fluorescence
NONE
Inscription(s)
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